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CONFIRMATION NO. 1339

SERIAL NUMBER 10/724,187	FILING DATE 12/01/2003  RULE	CLASS 117	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 117904
<b>APPLICANTS</b>  Tae Wan Lee, Seoul, KOREA, REPUBLIC OF;  Kyu Jin Choi, Kyunggi-do, KOREA, REPUBLIC OF; Jung Hoon Sun, Kyunggi-do, KOREA, REPUBLIC OF; Sung Jin Whoang, Kyunggi-do, KOREA, REPUBLIC OF; Bok Won Cho, Kyunggi-do, KOREA, REPUBLIC OF;				
<b>** CONTINUING DATA *****</b> <i>None</i>				
<b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 2002-75765 12/02/2002				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** SMALL ENTITY ** ** 03/12/2004				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Verified and Acknowledged	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 2	TOTAL CLAIMS 9	INDEPENDENT CLAIMS 1
<b>ADDRESS</b> 25944 OLIFF & BERRIDGE, PLC P.O. BOX 19928 ALEXANDRIA, VA 22320				
<b>TITLE</b> Method for forming silicon epitaxial layer				
		<input type="checkbox"/> All Fees		